Docket No.: 8733.657.10-US

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Yun-Ho Jung

Customer No.: 30827

Application No.: Not Yet Assigned

Confirmation No.: Not Yet Assigned

Filed: March 31, 2004

Art Unit: Not Yet Assigned

For: SILICON CRYSTALLIZATION METHOD Examiner: Not Yet Assigned

INFORMATION DISCLOSURE STATEMENT (IDS)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement accompanies the new divisional patent application submitted herewith.

Copies of the references on the PTO/SB/08 are not provided.

Those patent(s) or publication(s) which are marked with a double asterisk (**) next to the Cite No. in the attached form PTO/SB/08 (facsimile) are not supplied because they were previously cited by or submitted to the Office in a prior application number 09/851,325 and relied upon in this application for an earlier filing date under 35 U.S.C. 120.

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 50-0911, under Order No. 8733.427.10-US. A duplicate copy of this paper is enclosed.

Dated: March 31, 2004

Respectfully submitted,

Registration No.: 51,640

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Attorney for Applicant

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				Application Number	Not Yet Assigned	
INFORMATION DISCLOSURE			SCLOSURE	Filing Date	March 31, 2004	
S	STATEMENT BY APPLICANT			First Named Inventor	Yun-Ho JUNG	
				Art Unit	Not Yet Assigned	
(use as many sheets as necessary)			necessary)	Examiner Name	Not Yet Assigned	
Sheet	11	of	1	Attorney Docket Number	8733.657.10	

U.S. PATENT DOCUMENTS						
Examiner	Cite	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines,	
Initials*	No.1	Number-Kind Code ² (if known)			Where Relevant Passages or Relevant Figures Appear	
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	No.1	Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)		Applicant of Cited Document		T ₆
	**	97/45827	12/04/1997	WO		+-
	**	JP 62-26884 (with Abstract)	2/4/1987	NEC CORP		╁
	**	JP 4-180686 (with Abstract)	6/26/1992	NEC CORP		\vdash

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant

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OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS					
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